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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

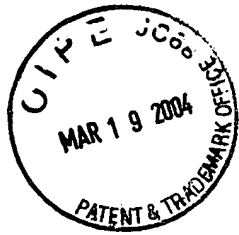
Applicant: Kie Y. Ahn et al.

Title: POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR

Docket No.: 303.377US3

Filed: July 20, 2001

Examiner: Maria Guerrero



Serial No.: 09/909532

Due Date: March 16, 2004

Group Art Unit: 2822

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ A return postcard.
- ☒ An Amendment and Response (10 Pages).
- ☒ Petition for Extension of Time (1 pg.)
- ☒ A check in the amount of \$950.00 to cover the Extension of Time Fee.
- ☒ A Communication Concerning Related Applications (1 pg.).

If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

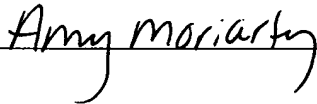
SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

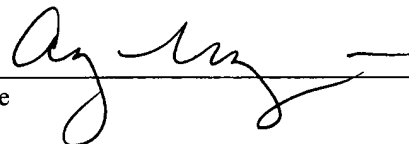
By: 
Atty: Timothy B. Clise
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 16th day of March, 2004.

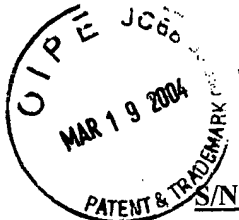
Name



Signature



SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
(GENERAL)



S/N 09/909532

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al. Examiner: Maria Guerrero
Serial No.: 09/909532 Group Art Unit: 2822
Filed: July 20, 2001 Docket: 303.377US3
Title: POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR

COMMUNICATION CONCERNING RELATED APPLICATION(S)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date</u>	<u>Attorney Docket</u>	<u>Title</u>
08/950319 6350704	October 14, 1997	303.377US1	POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR
09/517029 6313518	March 2, 2000	303.377US2	POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR
10/083051 6710428	February 26, 2002	303.377US4	POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR

Respectfully submitted,

KIE Y. AHN ET AL.

By Applicants' Representatives,

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16 March '04

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Name

Amy Moriarty

Signature

[Signature]